

Message Text

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PAGE 01 PARIS 15917 311744Z

ACTION EB-07

INFO OCT-01 EUR-12 ISO-00 SSO-00 USIE-00 DODE-00

NSAE-00 TRSE-00 ERDA-05 CIAE-00 COME-00 /025 W

-----311748Z 008143 /43

O 311631Z MAY 77

FM AMEMBASSY PARIS

TO SECSTATE WASHDC IMMEDIATE 0000

C O N F I D E N T I A L PARIS 15917

USOECD

EXCON

E.O. 11652: XGDS1

TAGS: ESTC, COCOM, PL, US

SUBJ: US POWER SEMICONDUCTOR MFG FACILITY TO POLAND,
IL 1355

REF: COCOM DOC (77) 309

1. GERMAN DEL MAINTAINED RESERVE ON REFCASE AT COCOM
MEETING 5/31 AND ASKED FOLLOWING QUESTIONS:

A. WHAT MEASURES WILL BE AVAILABLE IF END-USER SHOULD
TRY TO CIRCUMVENT SAFEGUARDS?

B. WILL KNOW-HOW BE DELIVERED? HOW HAS THE US
ASSURED ITSELF THAT NO OTHER ITEMS THAN SEMI-CONDUCTOR
DEVICES MENTIONED IN REQUEST WILL BE MFGD BY POLES?

C. GERMAN DEL ALSO WISHES LEARN CAPACITY CHARACTERIS-
TICS OF THE SEVEN DIFFUSION FURNACES TO BE ABLE TO
DETERMINE THE NECESSITY OF THE PROPOSED EXPORT.

2. USDEL REFERRED TO INFORMATION PROVIDED IN COCOM DOC
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(77) 309.2 AS PARTIAL RESPONSE TO GERMAN DEL AND RE-
QUESTED THAT GERMAN AND UK DELS REACH A FINAL
POSITION ON REFCASE AS QUICKLY AS POSSIBLE.

3. ACTION REQUESTED: INSTRUCTIONS FOR FURTHER RES-
PONSE TO GERMAN QUESTIONS.

KATZ

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NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01-Jan-1994 12:00:00 am
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: POLICIES, INSTRUCTIONS, STRATEGIC TRADE CONTROLS, EXPORT LICENSES, END USE CHECKS, SEMICONDUCTOR DEVICES
Control Number: n/a
Copy: SINGLE
Sent Date: 31-May-1977 12:00:00 am
Decaption Date: 01-Jan-1960 12:00:00 am
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 22 May 2009
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1977PARIS15917
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D770193-0477
Format: TEL
From: PARIS USOECD
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1977/newtext/t1977052/aaaaabqe.tel
Line Count: 62
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: 4f64498a-c288-dd11-92da-001cc4696bcc
Office: ACTION EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 2
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 02-Mar-2005 12:00:00 am
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2377644
Secure: OPEN
Status: NATIVE
Subject: US POWER SEMICONDUCTOR MFG FACILITY TO POLAND, IL 1355
TAGS: ESTC, PL, US, GE, COCOM
To: STATE
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/4f64498a-c288-dd11-92da-001cc4696bcc
Review Markings:
Margaret P. Grafeld
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